## Soft Science

### **Supplementary Materials**

A skin-wearable and self-powered laminated pressure sensor based on triboelectric nanogenerator for monitoring human motion

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**Supplementary Figure 1.** Scanning electron microscopy (SEM) images. (A) Pristine PDMS after peeling off from mold; (B) O<sub>2</sub> plasma treated (O-PDMS), and the magnified view of O-PDMS top surface; (C) The cross-sectional view of tribo-positive layer PMMA coated on ITO/Cu electrode.



**Supplementary Figure 2.** SEM and energy dispersive x-ray (EDX) analysis of cracked Cu and ITO-filled crack in Cu deposited on O-PDMS. (A) SEM image of a crack on Cu electrode deposited on O-PDMS with magnified image of crack (inset); (B) ITO-filled crack on Cu/O-PDMS; (C) EDX spectra of crack on the Cu/O-PDMS; and (D) EDX spectra of ITO-filled crack of Cu/O-PDMS.

The SEM image [Supplementary Figure 2B] clearly displays the ITO-filled crack. The EDX spectra of cracked copper [Supplementary Figure 2C] indicate the presence of silicon (Si) originating from the PDMS substrate. This suggests that there was no electrical path through the crack. Conversely, in the EDX spectra of the crack filled with ITO [Supplementary Figure 2D], the highest atomic percent was attributed to indium. Additionally, the electrical conductivity measurements for the copper electrode and ITO/Cu electrode yielded values of 8.7 and 75.8 S/m, respectively. These findings imply that the inclusion of an ITO layer within the cracks on the copper electrode establishes a conductive layer, thereby enhancing the overall conductivity and performance of the electrode.



**Supplementary Figure 3.** The output voltage of PTFE film under triboelectric contact with PDMS, Kapton tape, and PMMA on ITO/Cu electrode.



**Supplementary Figure 4.** The cyclic output voltage output as a function of tapping frequency (2, 3, and 4 Hz) at tapping force 6.3 N, and different separation gaps (A) Separation gap, d = 2 mm; (B) d = 3 mm; (C) d = 4 mm; (D) d = 4 mm.



Supplementary Figure 5. The rectified current output at various ohmic loads from  $10^3$  to  $2 \times 10^9 \Omega$ .

**Supplementary Table 1.** Triboelectric series of some commonly used materials according to the tendency of accepting electrons (tribo-negative) to donating electrons (tribo-positive). When two materials are far apart on the triboelectric series, more effective charge transfer takes place.

	Glass	Polychlorobutadiene	Ne	
	Wool	Natural rubber	gative	
	Polyamide 6-6 (Nylon)	Polyacrilonitrile		
	Silk	Polybisphenol carbonate		
Positive	Aluminium	Polychloroether	_	
	Paper	Polyvinyline chloride		
	Cotton	Polystyrene		
	Steel	Polyethylene		
	Wood	Polypropylene (PP)		
	Copper	Polyvinylidene fluoride (PVDF)	-	
	Silver	Polyimide (Kapton)		
	Polymethyl methacrylate (PMMA)	Polyvinyl chloride (PVC)		
	Polyvinyl alcohol (PVA)	Polydimethylsiloxane (PDMS)		
	Polyester	Polytetrafluoroethylene (PTFE)		

Authors	Active Materials	Sensitivity	Sensitivity
		Range-I	Range-II
		(0.0245-1.23 kPa)	(2.45-23.3 kPa)
Liu et al. <sup>[1]</sup>	PDMS microsphere-FEP	150 V/kPa, 26.6 V/kPa	Not reported
		(0.005-0.18 kPa) (0.18-1	
		kPa)	
Zheng et	Chitosan-FEP film	Not reported	46.03 V/kPa
<i>al</i> . <sup>[2]</sup>			(1.25-6.25 kPa)
Zhong <i>et</i>	Wire mesh-structured	44.31 V/kPa	7.16 V/kPa
<i>al</i> . <sup>[3]</sup>	PDMS	(0.006-2 kPa)	(2-8.5 kPa)
Zhu et al. <sup>[4]</sup>	Fluorinated ethylene	44 V/kPa	0.5 V/kPa
	propylene	(0.03-0.15 kPa)	(2-10 kPa)
	(FEP)-PET/ITO		
Garcia et	PVDF/ PVP electrospun	8.8 V/kPa, 3.9 V/kPa	Not reported
al. <sup>[5]</sup>	fibers	(0.2-0.8 kPa) (0.8-1.6	
		kPa)	
This work	PDMS encapsulated	7.287 V/kPa	0.663 V/kPa
	PTFE-PMMA thin film	(0.0245-1.23 kPa)	(2.45-23.3 kPa)
Rao et al. <sup>[6]</sup>	PDMS-BiTO/rGO/PVDF	5.07 V/kPa	1.89 V/kPa
		(0.2-1.72 kPa)	(1.72-3.65 kPa)
He <i>et al</i> . <sup>[7]</sup>	PDMS-PI-Cu	Not reported	0.367 V/kPa
			(3-45 kPa)
Rasel et	PDMS-PDMS/CNT	Not reported	0.35 V/kPa
al. <sup>[8]</sup>	Micro structured by		(5- 50 kPa)
	sandpaper		
Cao <i>et al</i> . <sup>[9]</sup>	Mxene on prestretched	2.35 V/kPa	0.14 V/kPa
	latex substrate	(0.3-1 kPa)	(1-50 kPa)
Lou et	PVDF/AgNW- conductive	1.67 V/kPa	0.20 V/kPa
<i>al</i> . <sup>[10]</sup>	PU fabric	(0-3 kPa)	(3-32 kPa)
Lin <i>et al</i> . <sup>[11]</sup>	PDMS ion	0.43 V/kPa	0.068 V/kPa
	hydrogel-PVDF-HFP	(0.01-1.5 kPa)	(100-700 kPa)

# Supplementary Table 2. Comparison of wide-range pressure sensitivity of LF-TENG with other TENG based pressure sensors

	core-shell fiber mats		
Zhao et	Cu-coated polyacrylonitrile	0.344 V/kPa	0.018 V/kPa
<i>al</i> . <sup>[12]</sup>	(Cu-PAN) yarns and	(0-0.25 kPa)	(0.25-37.5 kPa)
	parylene coated Cu-PAN		
Wang et	PDMS-A1	Not reported	0.06 V/kPa
<i>al</i> . <sup>[13]</sup>			(1-80 kPa)
Pu <i>et al</i> . <sup>[14]</sup>	PAAm-LiCl	Not reported	0.013 V/kPa
	hydrogel/PDMS		(1.3-70 kPa)

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